

IWJT2025, 25th Anniversary **22nd International Workshop** on Junction Technology



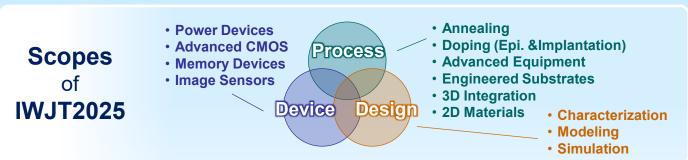
June 5th-6th (Thu.-Fri.), 2025, Kyoto University, Uji Campus

Conference Website https://smartconf.jp/content/iwjt2025/

The IWJT, started in 2000 and was held annually in Japan or China, is an open forum focused on the needs and interests of the community on a junction formation technology in semiconductors. The workshop will provide a good opportunity for researchers and engineers to present their new research results, and exchange ideas with leading scientists.

Deadline of full manuscript (2-4 pages) submission: April 4th, 2025

Best Paper Award and Young Award (under 35 age on the workshop day) will be selected. Detail can be seen in the conference website.



Committees

General Chair : Satoshi Shibata (Panasonic Operational Excellence Co., Ltd.) Executive Chair : Osamu Nakatsuka (Nagoya University) Program Chair : Tetsuo Narita (Toyota Central R&D Labs., Inc.)

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